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Response

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:  
Landon B. Vines *et al.*  
Serial No. 09/871,507  
Filed: 5/31/2001  
For: A CMP Polisher Substrate Removal Control  
Mechanism and Method

Group: 3723  
Examiner: Willie Berry, Jr.  
Docket No.: US 018074

**RESPONSE TO FEBRUARY 6, 2003 OFFICE ACTION**

Assistant Commissioner for Patents  
Washington, DC 20231

Sir:

In response to the Office Action dated February 6, 2003, please consider the following amendments and remarks. Please note that an SB-122 Change of Correspondence Address has been included with this Office Action Response.

Introductory Comments

Applicants appreciate Examiner's withdrawal of the finality of the previous Office Action and continuing the examination of the present application. Applicants respectfully request his thoughtful consideration of the discussion presented and allowance of the claimed invention. Claims 1 – 20 remain pending in the application.

**FACSIMILE TRANSMISSION  
TO THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**TO: EXAMINER Willie Wendell Berry, Jr.**  
**ART UNIT 3723**  
**EXAMINER'S FAX NUMBER (703) 872-9302**

**FROM: Peter S. Zawilski**

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**FAX RECEIVED**  
**MAY 01 2003**  
**GROUP 3700**

**RE: SERIAL NO. 09/871,507**  
**DOCKET NO. US 018074**

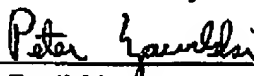
**8 Pages (including cover sheet)**

**This transmission includes:**

**SB-122 Change of Correspondence Address (1 pg.)**  
**Response to Office Action 02-FEB-2003 (6 pgs.)**

**Certificate of Transmission under 37 CFR 1.8**

I hereby certify that this correspondence is being facsimile transmitted to the Patent and Trademark Office  
on May 1, 2003.

  
Peter Zawilski

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